



PATENT
8070-1003

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Tatsuya SUZUKI et al.

Conf. 7159

Appl. No. 10/685,571

Group 2812

Filed October 16, 2003

Examiner W.Lindsay, Jr.

METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 11, 2005

Sir:

In response to the Office Action mailed March 10, 2005,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

An **Appendix**, including a verified English translation
of the priority Japanese application, is attached following the
signature page of this paper.